

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

---

In re Patent Application of:  
Selena Chan et al.

Application No.: 10/667,004

Confirmation No.: 6646

Filed: September 19, 2003

Art Unit: 1634

For: CONTROLLED ALIGNMENT OF  
NANOBARCODES ENCODING SPECIFIC  
INFORMATION FOR SCANNING PROBE  
MICROSCOPY (SPM) READING

---

Examiner: F. W. Lu

**REQUEST FOR ACKNOWLEDGMENT OF IDS**

MS Issue Fee  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Notice of Allowance, dated September 8, 2008, Applicants respectfully request the Examiner's acknowledgment of the Information Disclosure Statement electronically filed on February 8, 2008. For the Examiner's convenience, we attach a copy of the as-filed Information Disclosure Statement hereto.

As the Issue Fee is due to be paid in this application by December 8, 2008, Applicants would appreciate receiving the Examiner's acknowledgement that the cited reference has been considered and made of record.

It is respectfully submitted that no fees are required for this filing, however, the Director is authorized to charge any applicable fees and/or credit any overpayments to Deposit

Application No. 10/667,004  
Communication dated November 20, 2008  
Request for Acknowledgment of IDS

Docket No.: 21058/1206448-US1

Account No. 04-0100 referencing docket no. 21058/1206448-US1.

Dated: November 20, 2008

Respectfully submitted,

By /Raj S. Dave/  
Raj S. Dave  
Registration No.: 42,465  
DARBY & DARBY P.C.  
P.O. Box 770  
Church Street Station  
New York, New York 10008-0770  
(212) 527-7700  
(212) 527-7701 (Fax)  
Attorneys/Agents For Applicant